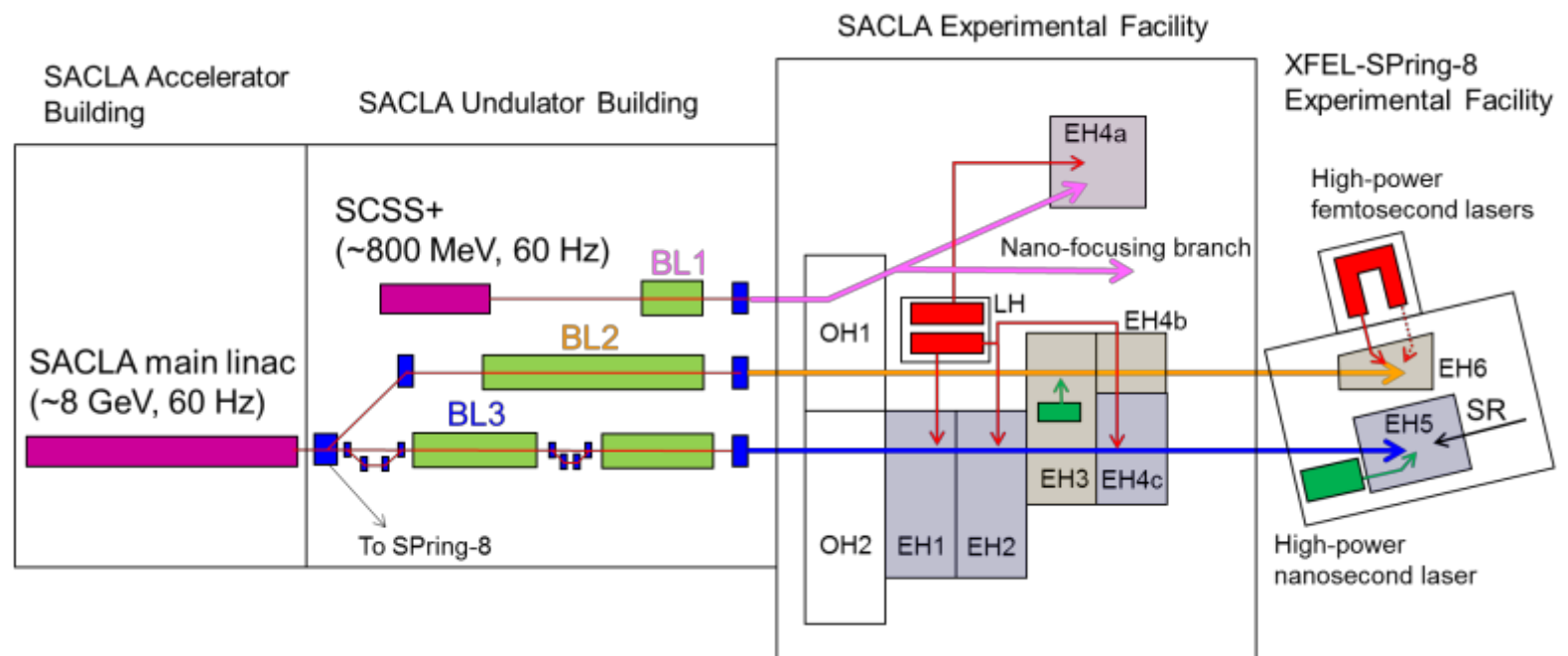


Updates on Beamlines

Kensuke Tono (SACLA)

Contents

1. Operation in 'phase 2'
2. Research highlights
3. New capabilities
4. Summary

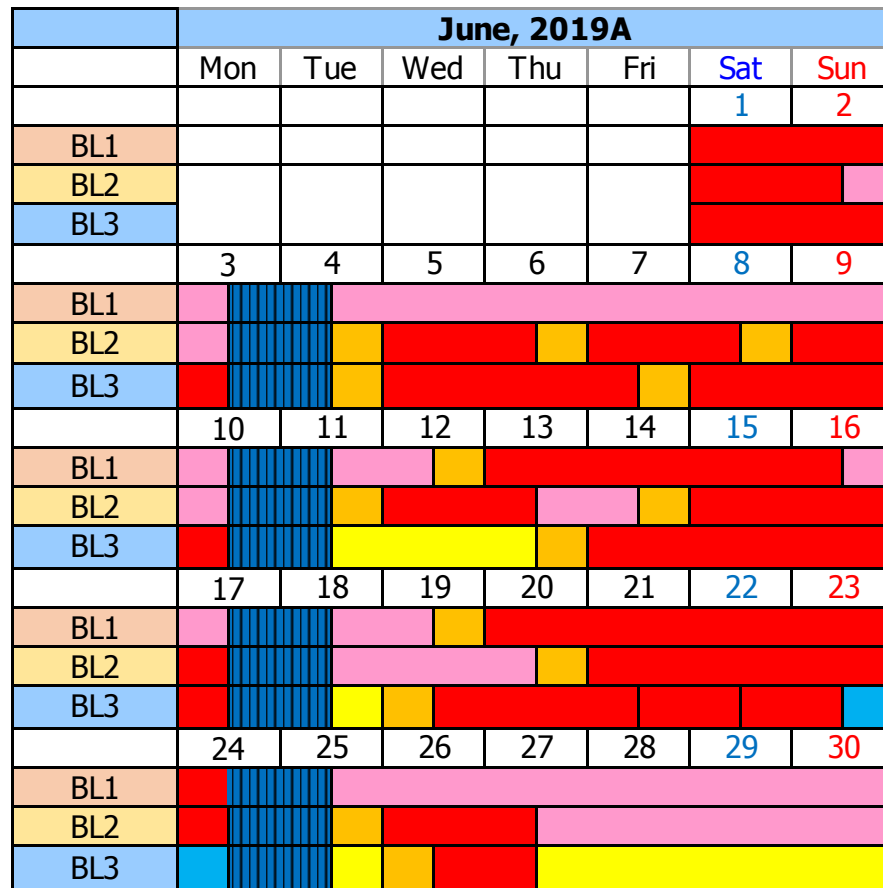


Operation 'Phase 2' for two years

- Parallel operation of 3 BLs from 2017B

Operation schedule (June 2019)

⇒ **Poster No.1, Inagaki-san**





 Machine tuning

 User time

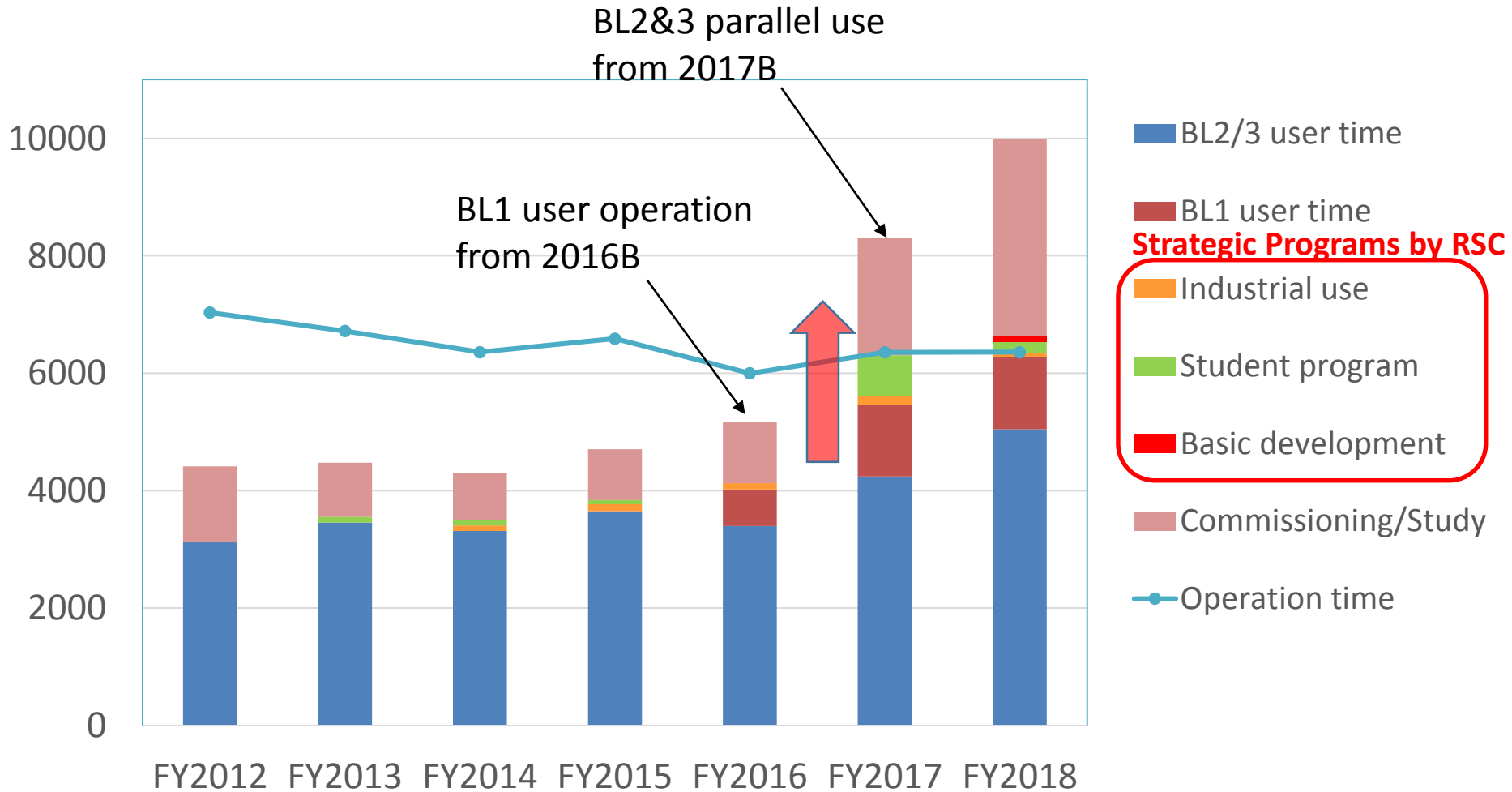
 Preparation for user time

 Commissioning

 Study (Graduate Student, Basic Development, In-house)

 Industry-Academy Partnership Program

Beamtime



Expanding opportunities in 'Phase 2'

- More user beamtime with 3 BLs
 - ⇒ 6,270 h user time in FY2018.
 - ⇒ Feasibility-check beamtime @BL2 (from 2017B)
 - ⇒ Beamtime allocation on a 12 h-a-day basis @BL2
- Opportunities for promotion programs
 - ⇒ SACLA Basic Development Program
 - ⇒ SACLA Research Support Program for Graduate Students
 - ⇒ SACLA Industry-Academy Partnership Program
- High-power lasers
 - ⇒ High power fs laser (500 TW): Open to users from 2018A.
 - ⇒ High power ns laser (ILE, Osaka U.)

Three beamlines

⇒ Poster No.2, Inubushi-san

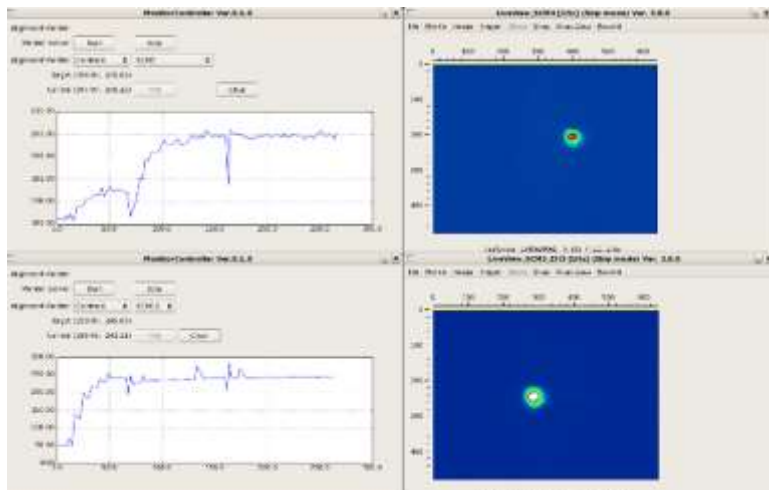
	Type of experiment	Major instruments	Remarks
BL1 (40-150 eV, higher-order harmonics)	Ion/electron spectroscopy SX spectroscopy Ellipsometry Imaging	fs optical laser KB (~5 μm) Timing tool Nano focusing optics Opto-spintronics platform	Users are encouraged to use their own end- stations
BL2 (4-15 keV)	Fixed-target PX SFX CDI/SAXS P&P with high power laser	ns optical lasers KB (~1 μm) DAPHNIS (SFX) MAXIC-S/II (CDI) High power fs laser	Feasibility-check beamtime
BL3 (4-20 keV)	XRD WAXS Spectroscopy SFX, CDI (fs resolution) XPCS Laser-shock compression	fs optical laser SDO Timing tool CRL, KB (~1 μm) 300 exa (~0.1 μm) High-power ns laser (Osaka U.)	Double-pulse XFEL (~300 fs delay@10 keV) Self-seeding Polarization control

The facility assigns BL2 or BL3 to HX-FEL users according to the type of experiment.

For more efficient operation

- Auto-positioning of XFEL beam/sample.

Auto tuning of BL optics

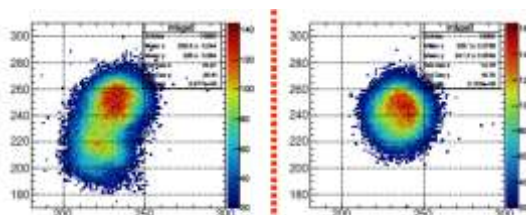


Sample injector (under development)

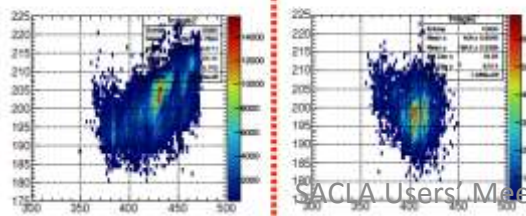


- Quick multiple-parameter optimization of XFEL (Intensity, bandwidth, beam size, etc.)

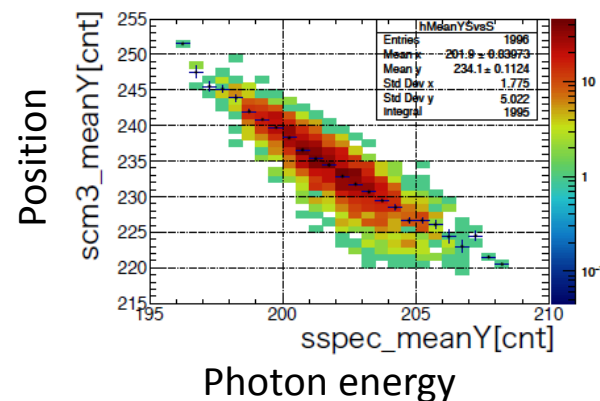
Beam profile



Spectrum



Photon-energy and position correlation

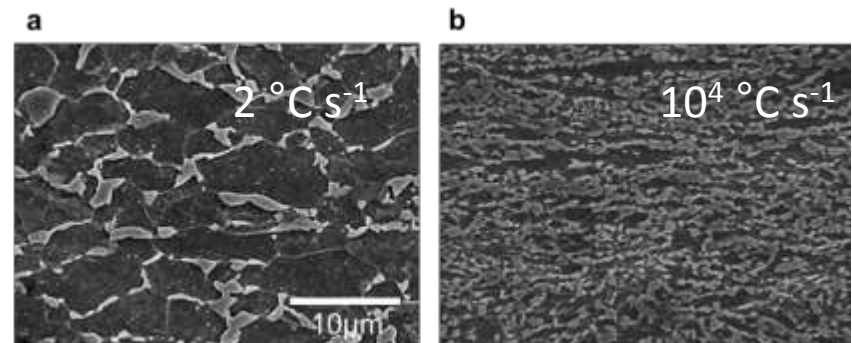
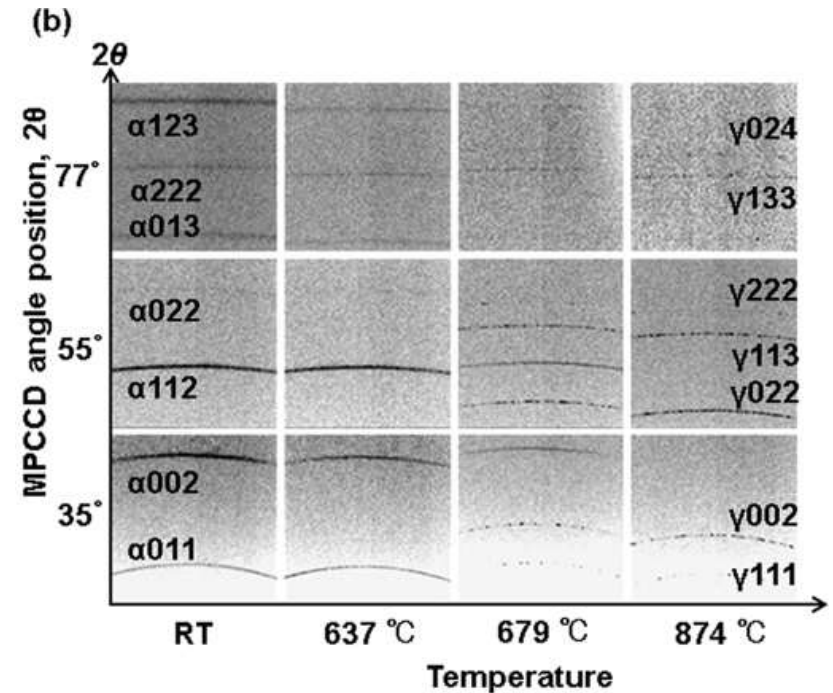
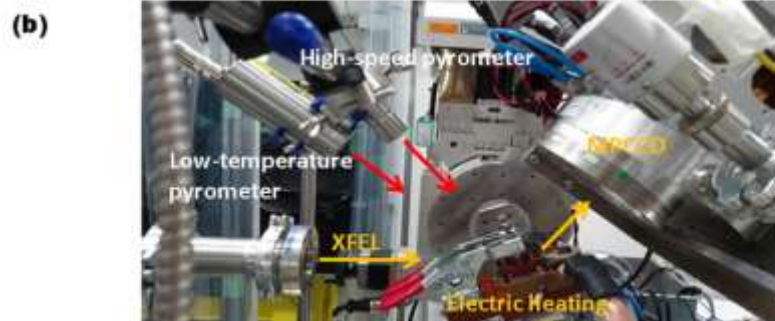
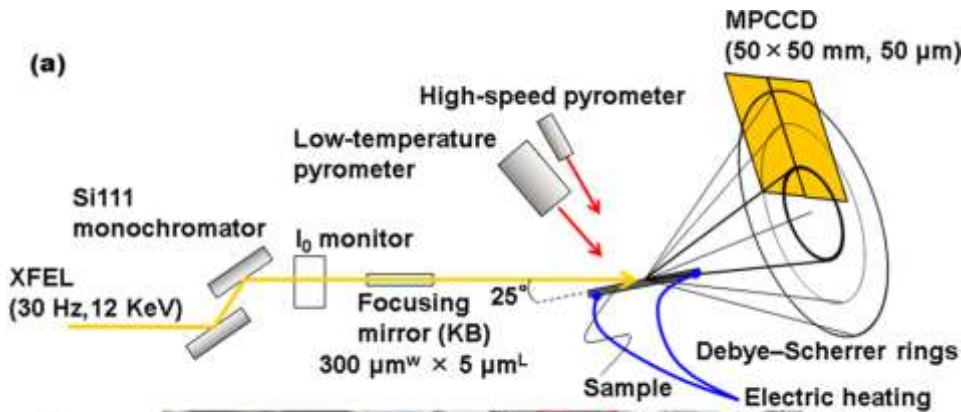


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Time-resolved XRD of steel under ultrafast heating process

Yonemura (Nippon Steel Co.) et al.,
Scientific Reports 9, 11241 (2019).

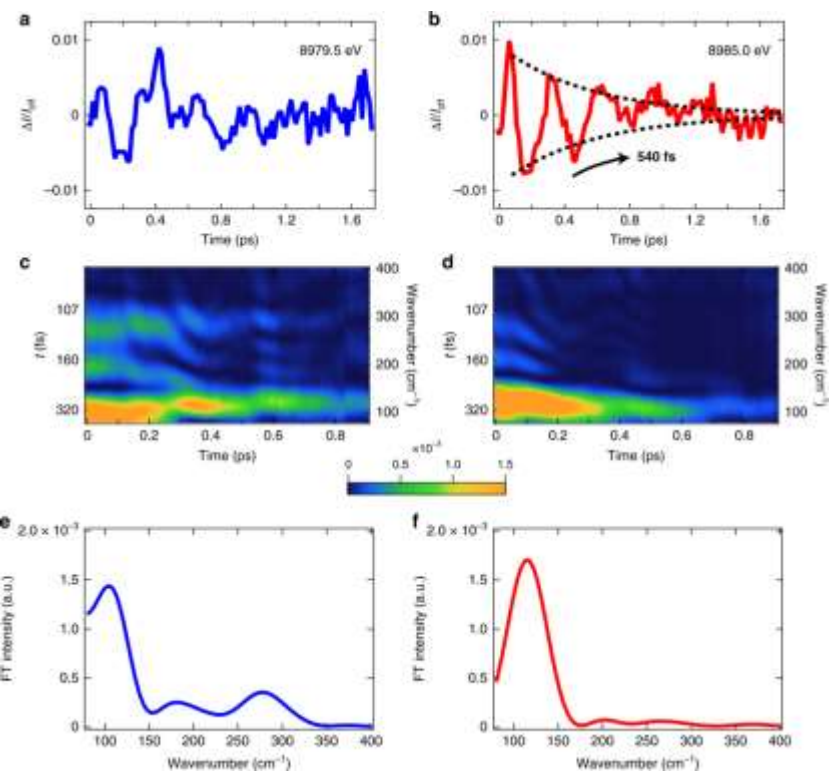
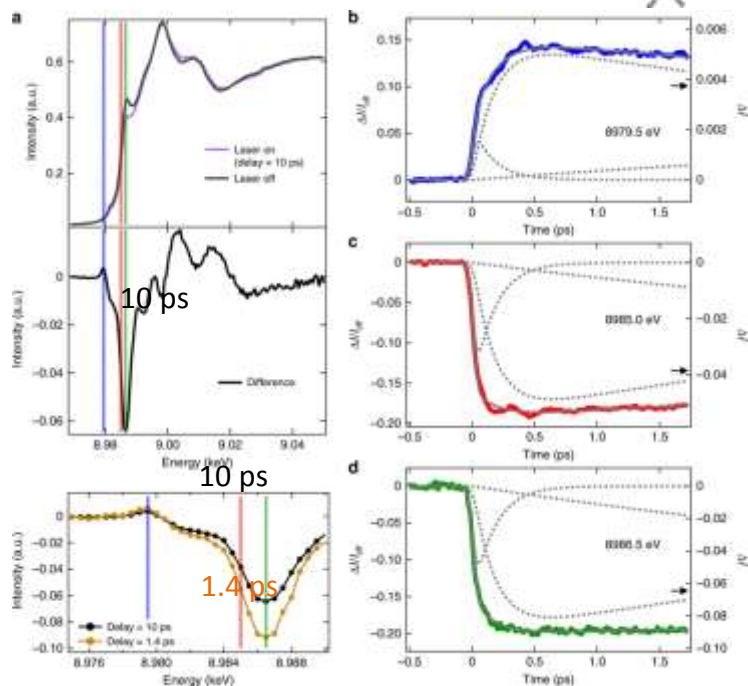
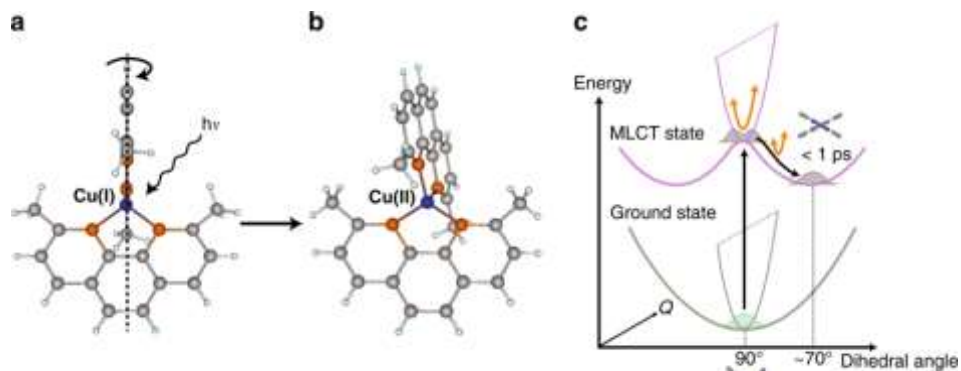


Ultrafast electrical heating at $\sim 10^4^\circ\text{C/s}$

Tracking a nuclear wavepacket using ultrafast X-ray spectroscopy

Photoexcited Cu(I)-phenanthroline

Katayama et al.,
Nat. Commun. **10**, 3606 (2019).



Probing ultrafast electronic decay processes in molecules

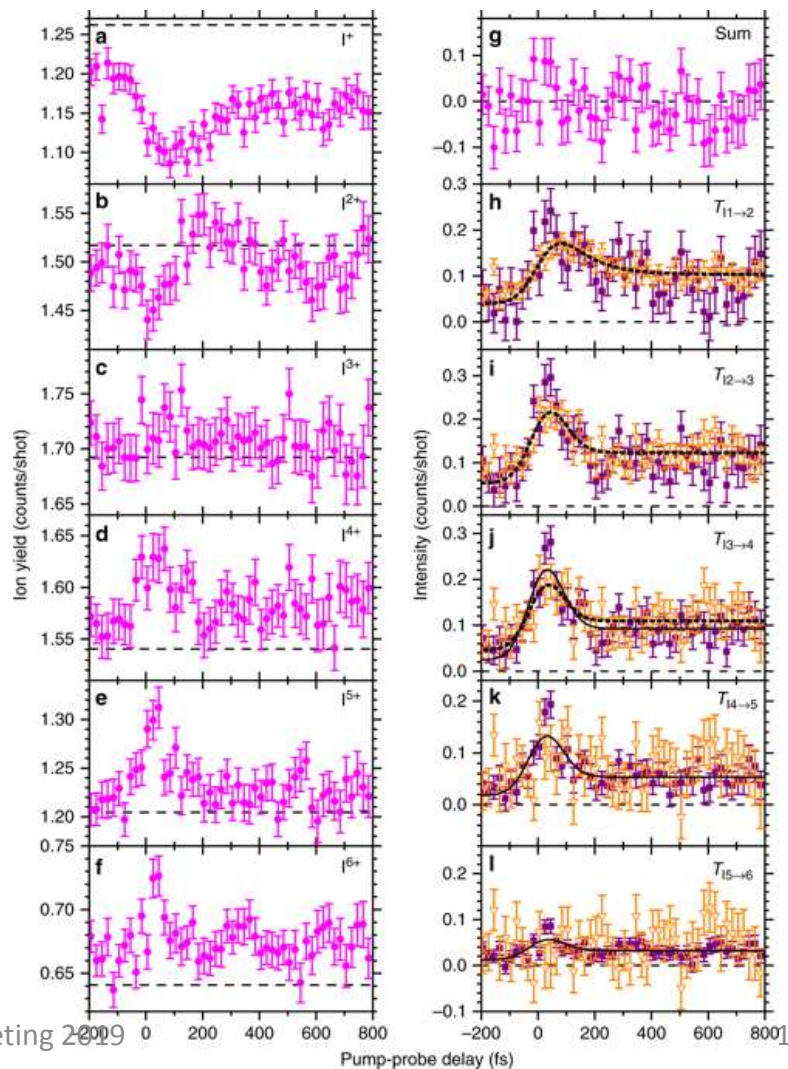
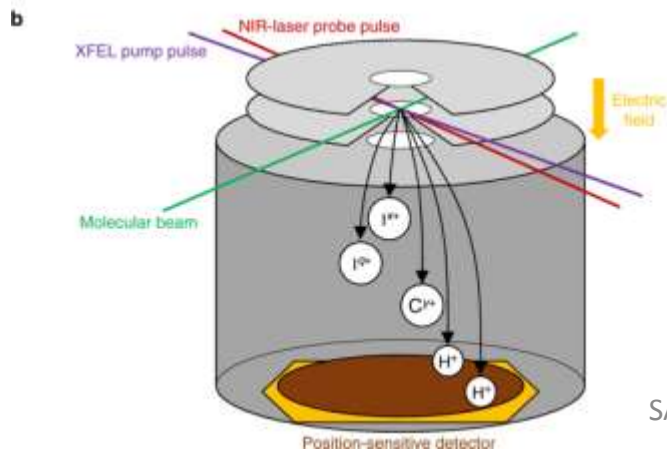
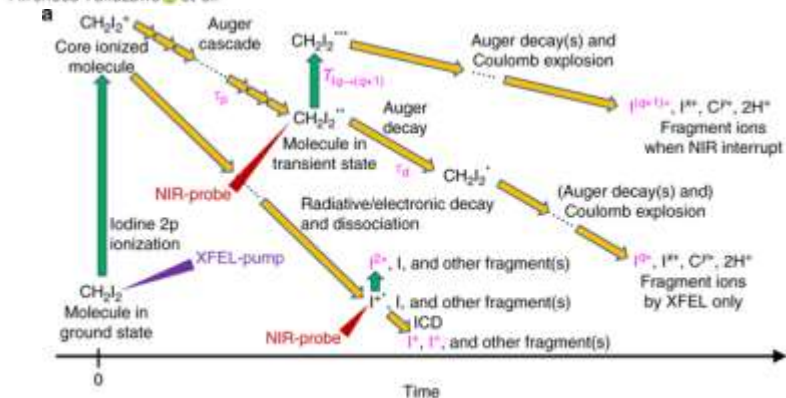
Fukuzawa, Ueda et al.,
Nat. Commun. **10**, 2186 (2019)

ARTICLE

<https://doi.org/10.1038/s41467-019-10040-z> OPEN

Real-time observation of X-ray-induced intramolecular and interatomic electronic decay in CH_2I_2

Hironobu Fukuzawa et al.^{1*}

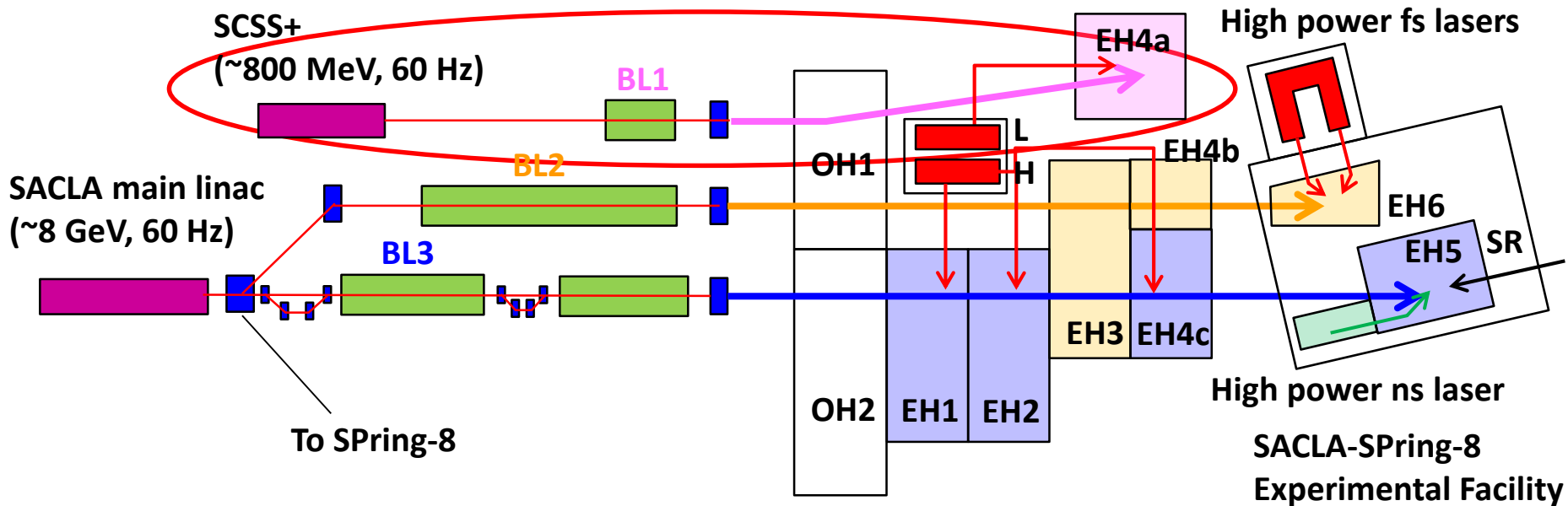


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BL1

- Nano focusing optics
- Experimental platform for opto-spintronics researches.



SX nano focusing system

Nano focusing branch of BL1

Collaboration with U. Tokyo

Motoyama-san, Mimiura-sensei => Talk
Egawa-san, Yamaguchi-san, Yokomae-san

=> Posters

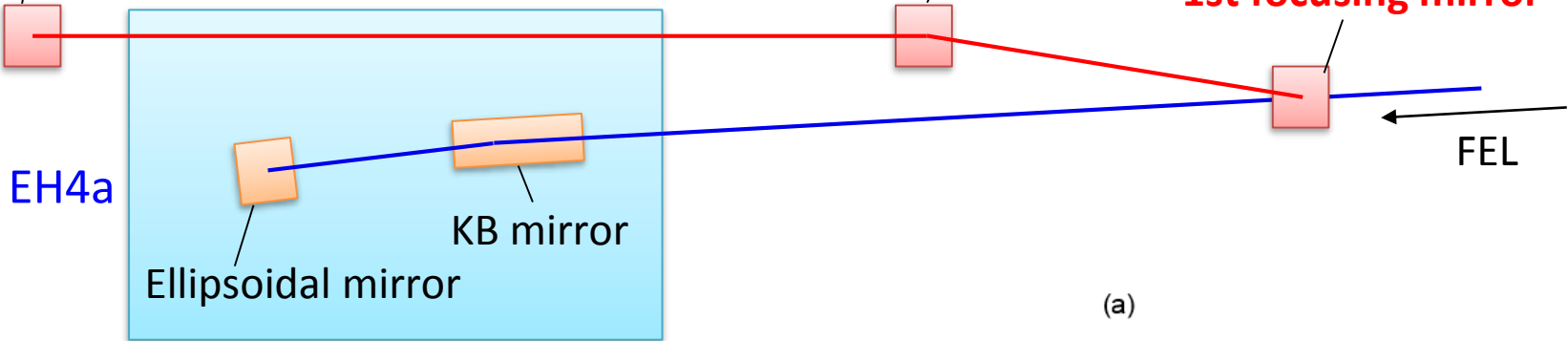
2nd focusing mirror

New branch

Plane mirror

1st focusing mirror

FEL

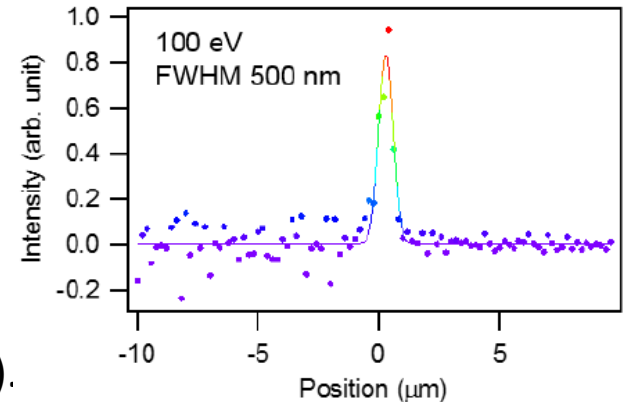


2nd focus

Source

1st focus

(a)



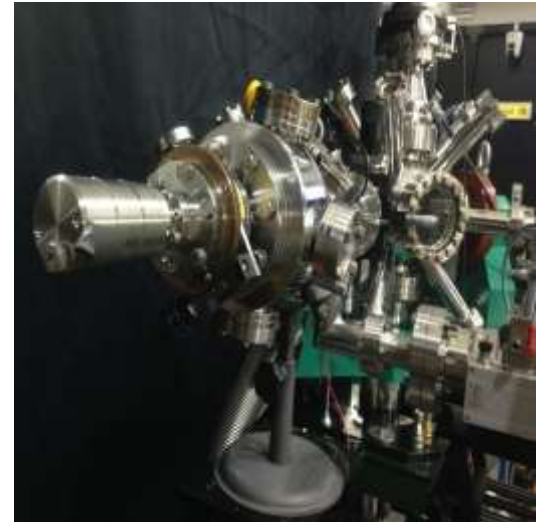
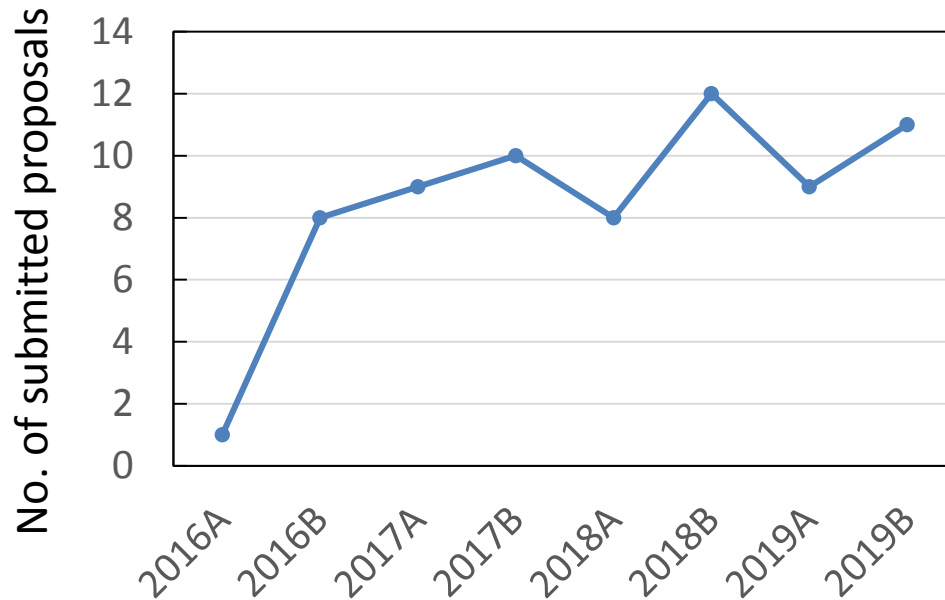
Motoyama et al., Proc. SPIE (2017); J. Synchrotron Rad. (2019).

Mimura et al., Rev. Sci. Instrum. (2018).

Egawa et al., Proc. SPIE (2019).

Experimental platform for materials science at BL1

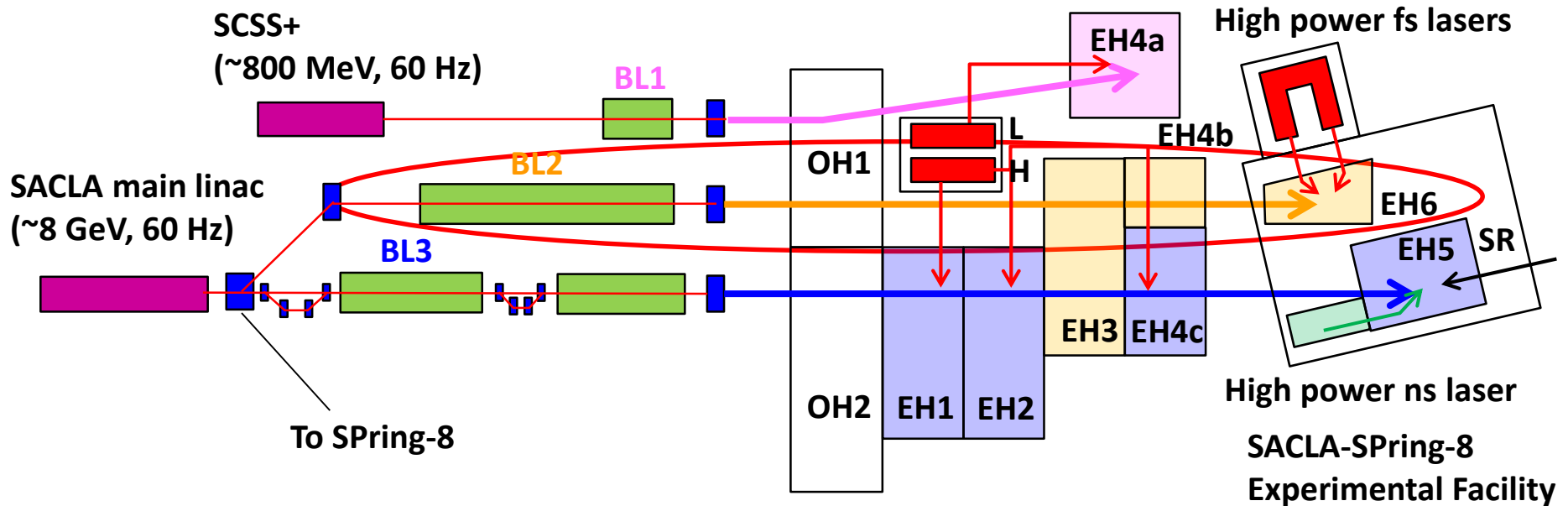
Number of proposals for BL1 (SX-FEL)



- Number of proposals tends to increase at BL1.
=> Common-use system will be useful.
- Experimental system for opto-spintronics researches is under development => **Dr. Hirata and Prof. Matsuda (U. Tokyo), Talk in the next session**

BL2

- MAXIC-S
- Large area detector (Rayonix MX-300HS)

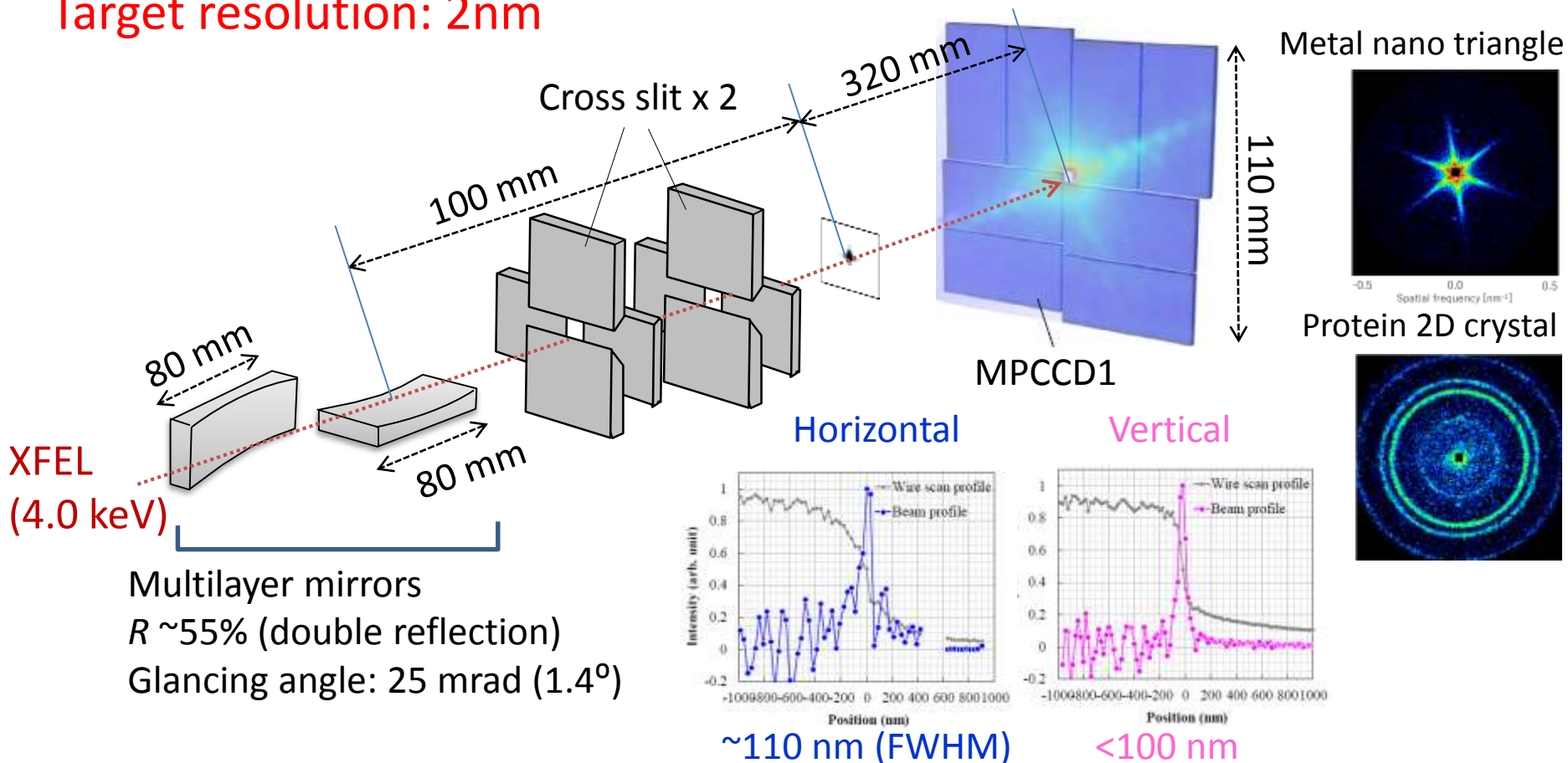


MAXIC-S for nano-beam CDI

BL2

Collaboration with Hokkaido U.
Suzuki-san, Nishino-sensei (Talk)

Target resolution: 2nm



Installed into EH4b for more efficient operation (this summer).



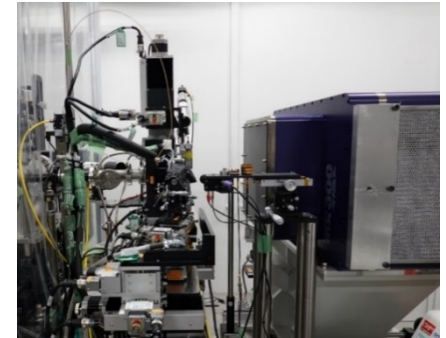
Large area detector for PX, WAXS

BL2

BL3

MX300-HS (Rayonix, L.L.C.) is now operated on the SACLA DAQ system.

Description	8 sensor MPCCD (Phase Ib)	MX300-HS*	
		2x2 binned	4x4 binned
Active area [mm ²]	110 x 110	300 x 300	
Max. frame rate [Hz]	60	10	33
Image format	2048 x 2048 50 μ m	3840 x 3840 78 μ m	1920 x 1920 156 μ m
Nominal Q.E. @12keV	0.2	0.8	0.8



DAPHNIS with MX300-HS

* <https://www.rayonix.com/product/mx300-hs/>

PX

For samples having large lattice constants. (longer camera distance).

WAXS

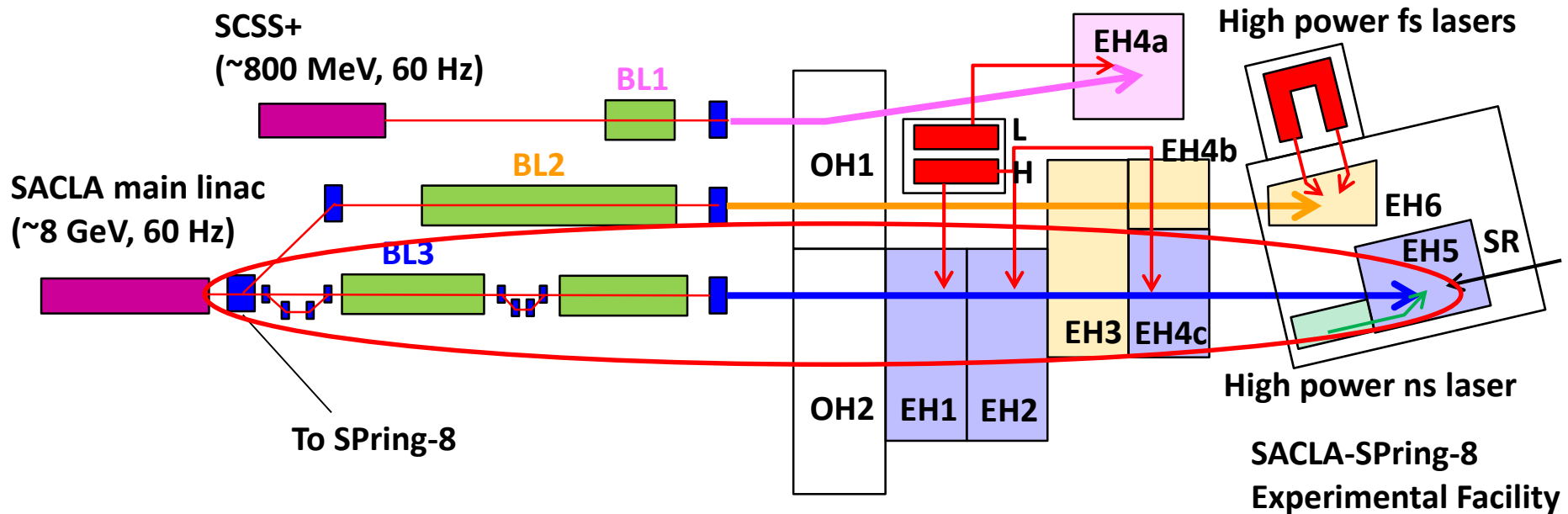
For wider angular range.

CITIUS detector will be technically available for SACLA.

- Small system (0.3M-pixel single sensor) from 2021.
- Deployment plan of larger area detectors will be determined after hearing user needs.

BL3

- Reflection self seeding
- Split-and-delay optics (SDO)
- Preparation for new sub-10 nm focusing system



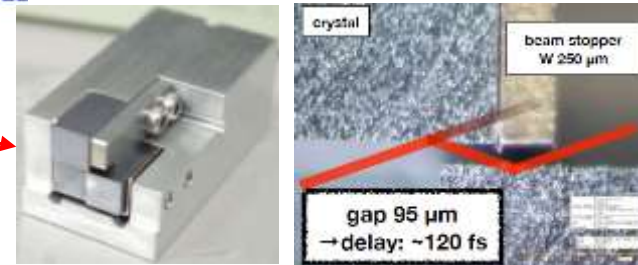
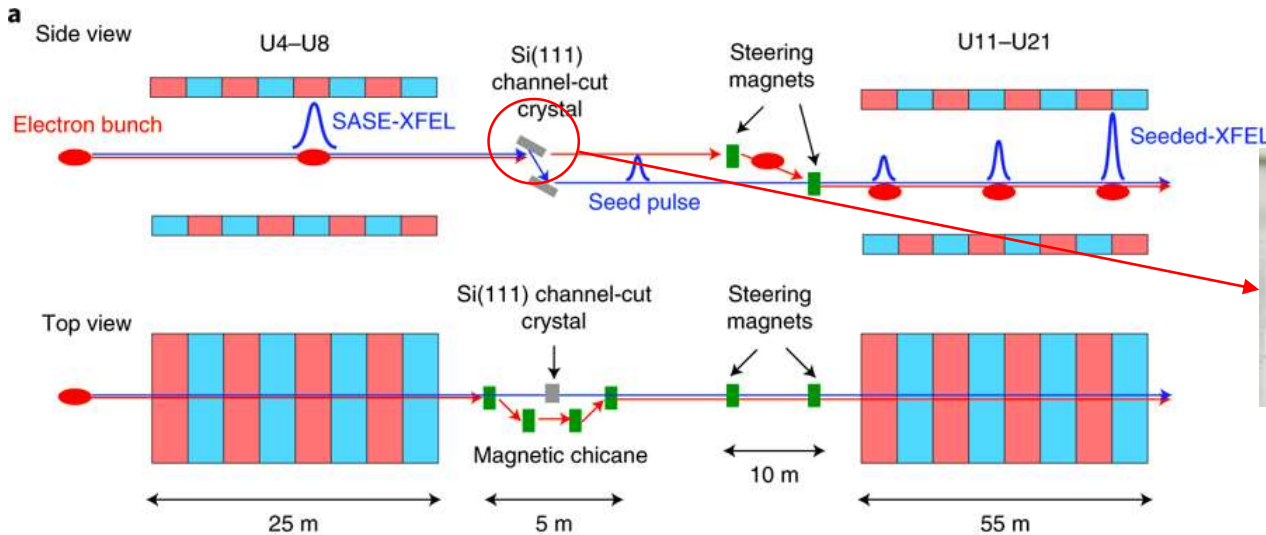
Reflection self-seeding

BL3

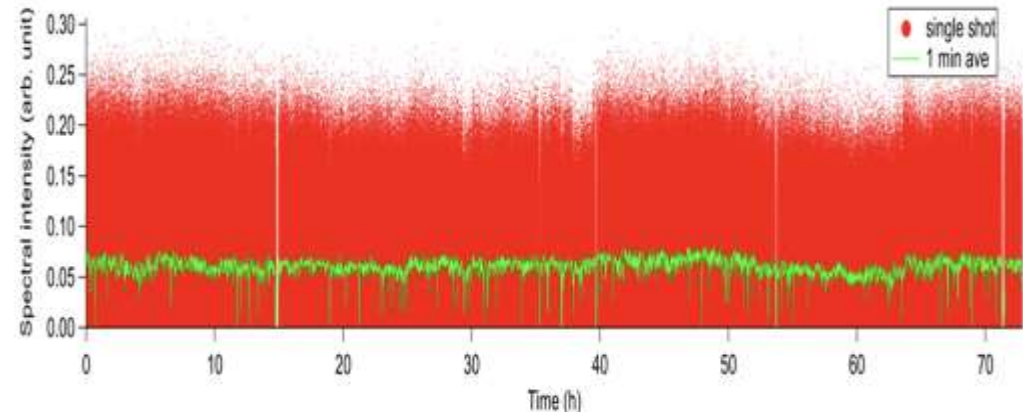
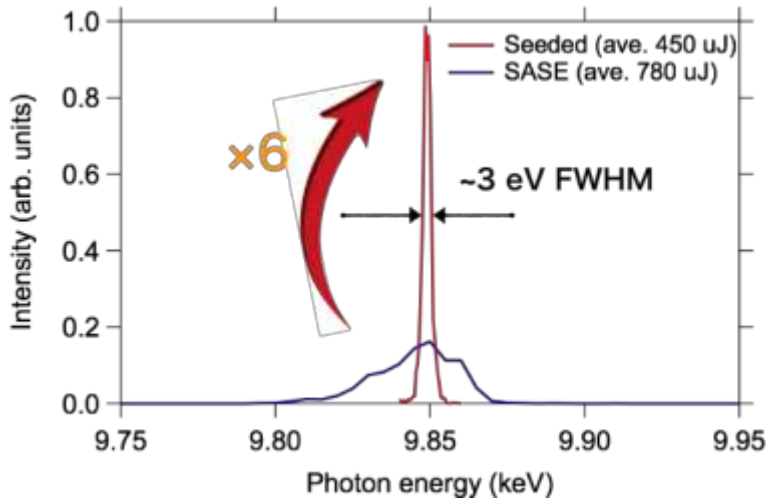
User operation from 2019A

⇒ Poster No.3, Inoue-san

Inoue, Osaka et al,
Nat. Photon. (2019)



Micro channel-cut crystal with a 95- μm gap



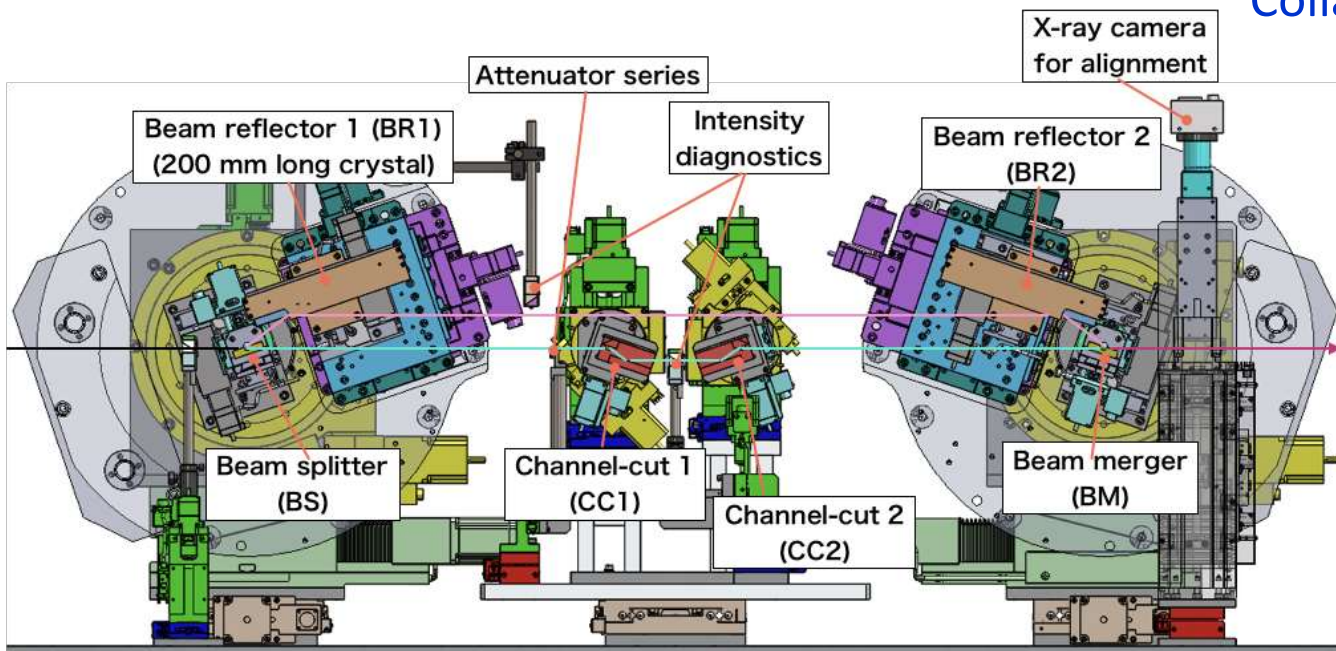
3-day trend of pulse energy after Si(111) DCM

- Seeded XFEL has been used in >10 users' experiments
- R&D is on going for achieving higher stability.

Hard X-ray split-and-delay optics (SDO) BL3

Open for user experiments from 2018B.

⇒ **Poster No.4, Osaka-san**
 Collaboration with Osaka U.



Photon energy range

5 – 15 keV

Time delay range

0 – >100 ps

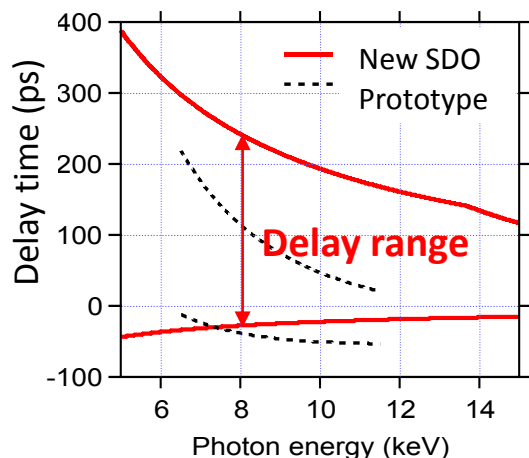
<1 fs delay step

Pulse energy of each pulse @10 keV

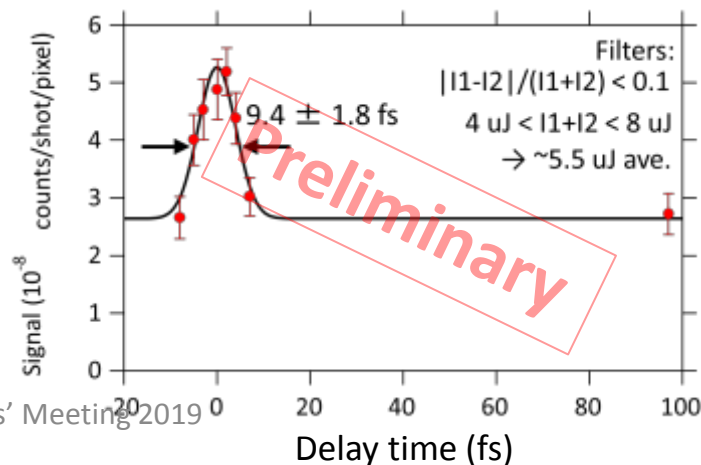
~0.3 μ J (SASE)

~1 μ J (self-seed)

Photon energy vs. range of delay time



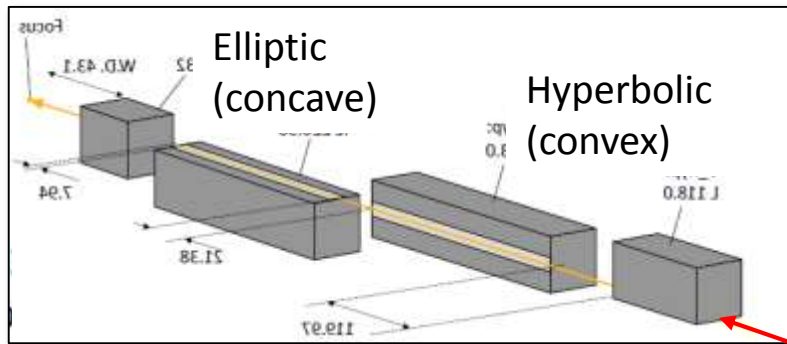
Autocorrelation measurement (preliminary)



For new sub-10 nm focusing system

Advanced KB system

Pair of hyperbolic & elliptic mirrors
(‘Wolter-III’)



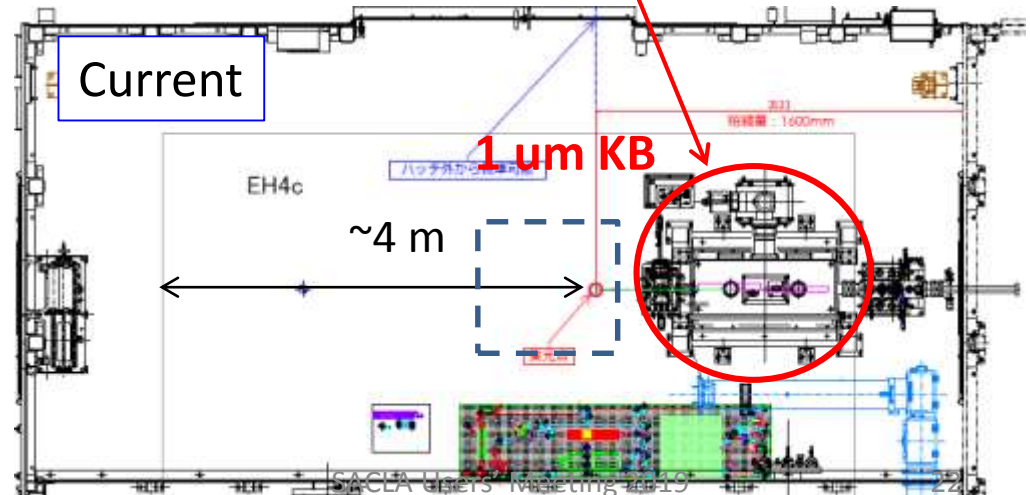
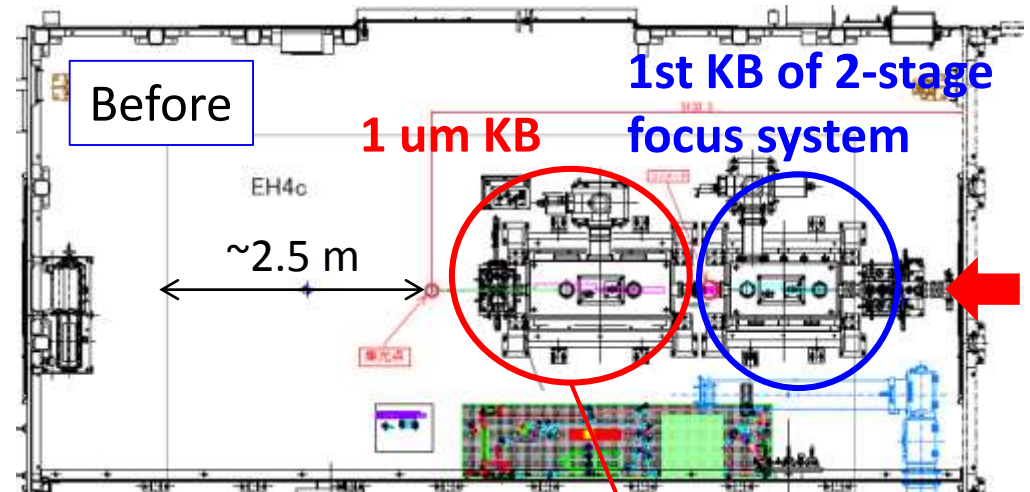
Collaboration with Osaka U.

⇒ Poster No.5, Yamada-san

⇒ Breakout session 1

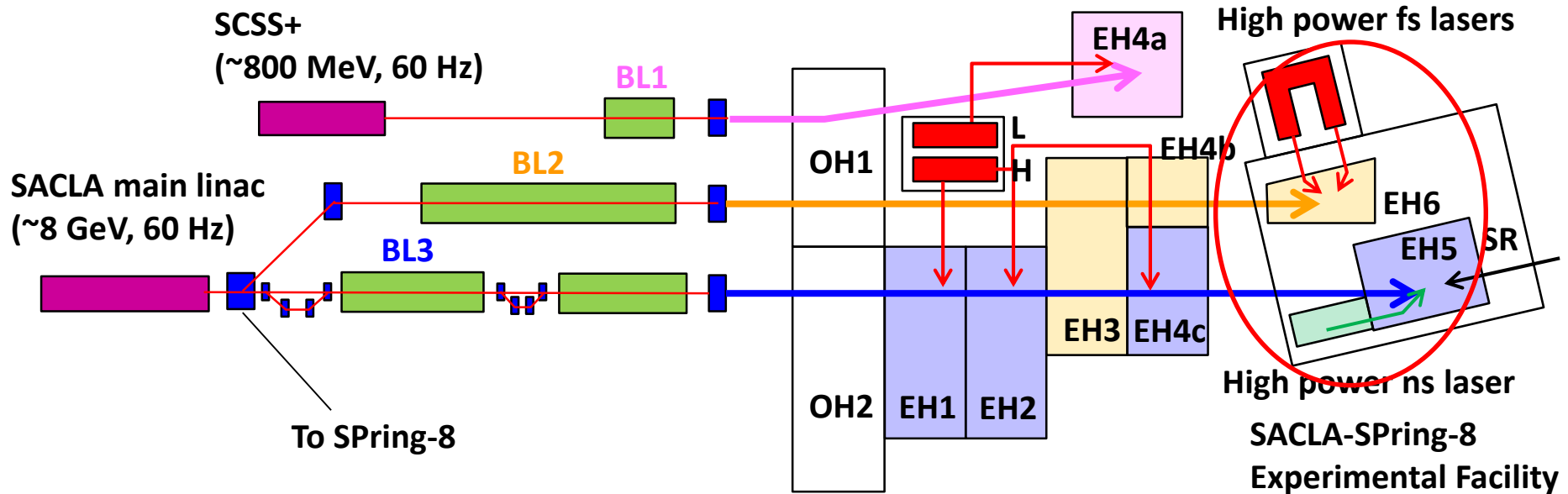
Commissioning has started at SPring-8.

Layout change in BL3 EH4c



High power lasers

- Femtosecond laser (BL2 EH6, 500 TW)
- Nanosecond laser (BL3 EH5, 100 J)



Current capabilities of experimental platform with high power fs laser at EH6

BL2

6 user experiments have been carried out.

Focusing Capability of XFEL

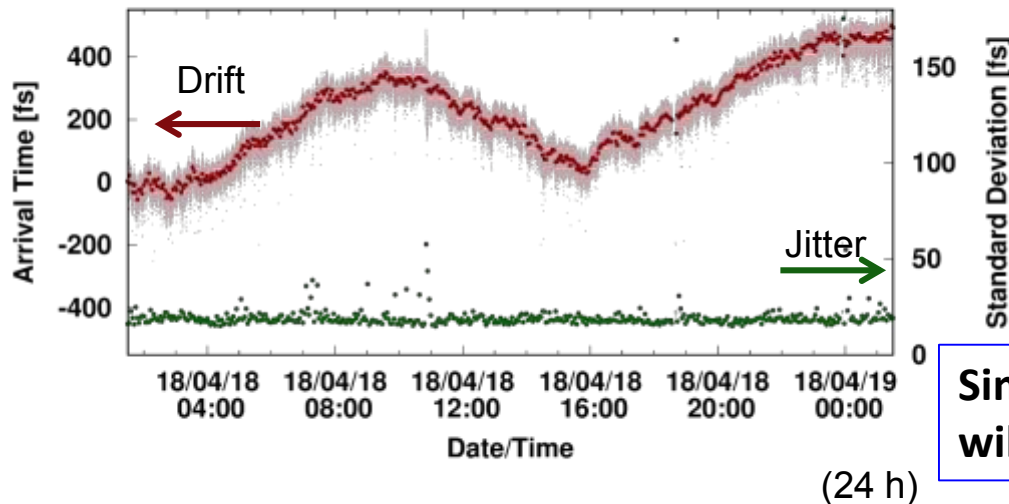
- Focused with sets of CRLs
- Minimum spot: a few μm (FWHM) on sample

Typical Specs of High Power Laser

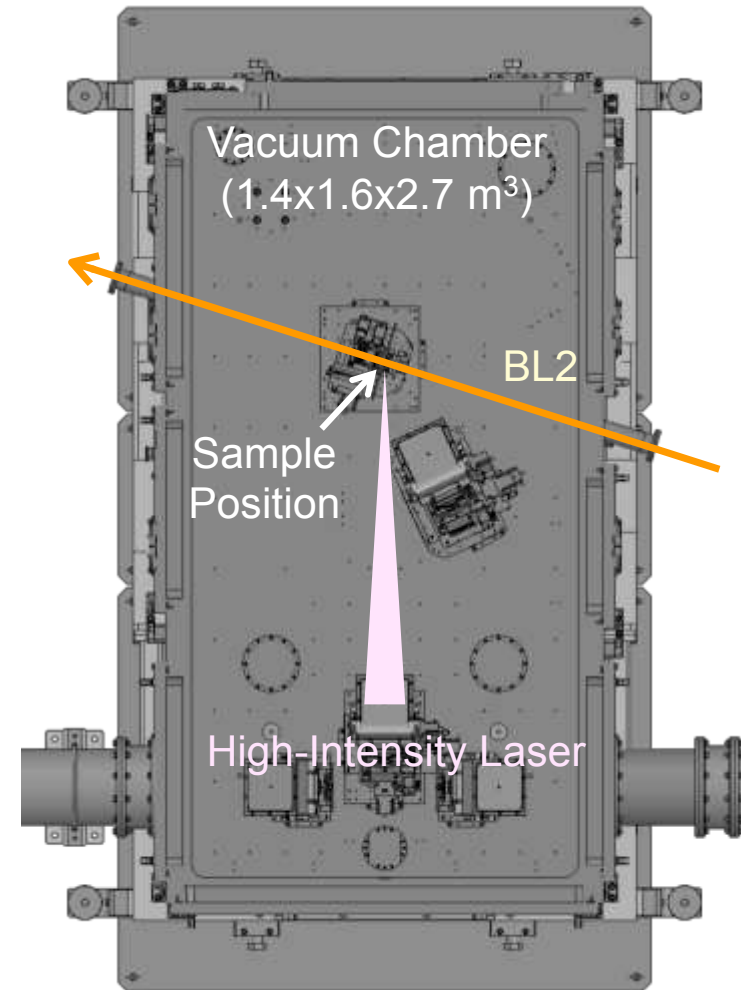
- One beam with f/10 off-axis parabolic mirror
- Maximum power: ~ 200 TW (~ 8 J/40 fs) on sample
- Minimum spot: ~ 20 μm (FWHM)
- Peak intensity: $\sim 10^{19}$ W/cm²

Temporal overlaps of XFEL and laser

- Jitter in short term (~ 5 m): **~ 20 fs (rms)**
- Drift in long term (~ 24 h): 0.7 – 1.0 ps



\Rightarrow Poster No.8, Yabuuchi-san



Similar synchronization system with BOM-PD will be applied to the fs synchronized lasers.

\Rightarrow Poster No.6, Owada-san

Experimental platform for combinative use of XFEL and high power ns laser

BL3

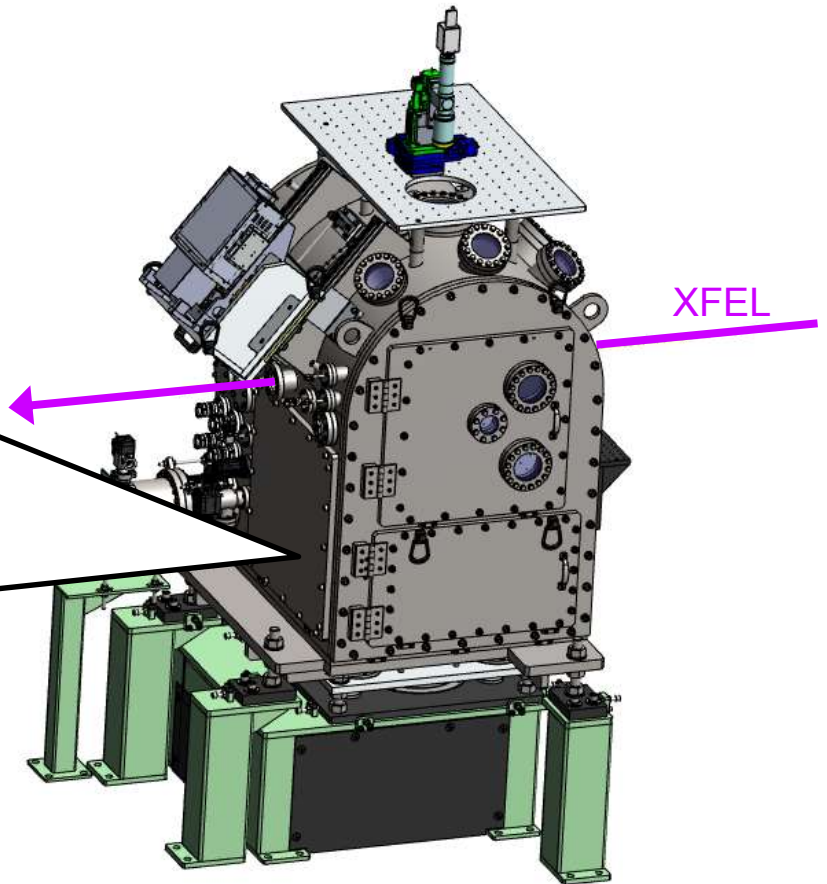
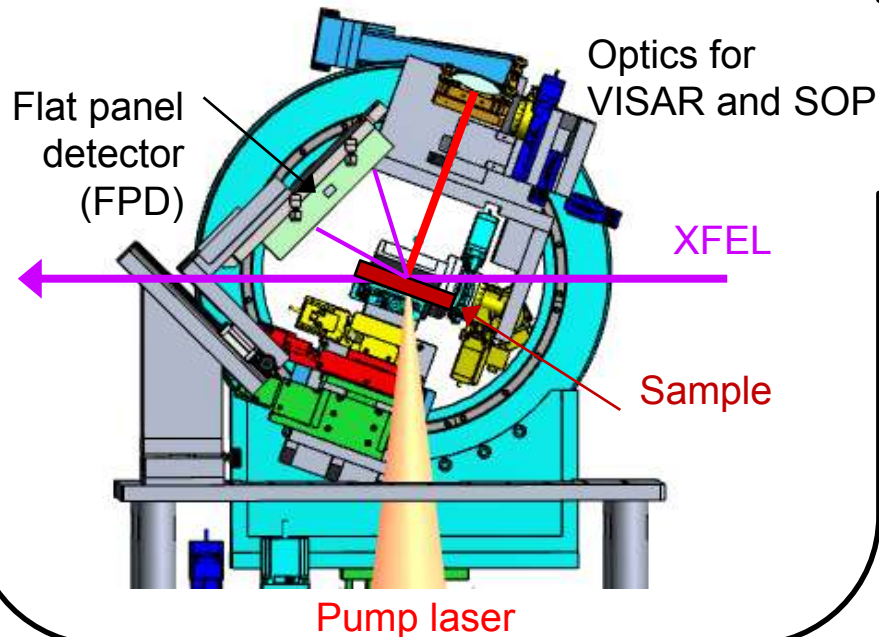
⇒ Poster No.7, Miyanishi-san

User operation from 2018B

100-J ns laser (ILE, Osaka U.)

- Pulse energy: ~100 J (max.)
- Wavelength: 532 nm
- Pulse duration: 3~10 ns (pulse shaping)
- Repetition rate: 0.1 Hz

Reflection geometry for X-ray diffraction measurement



Summary

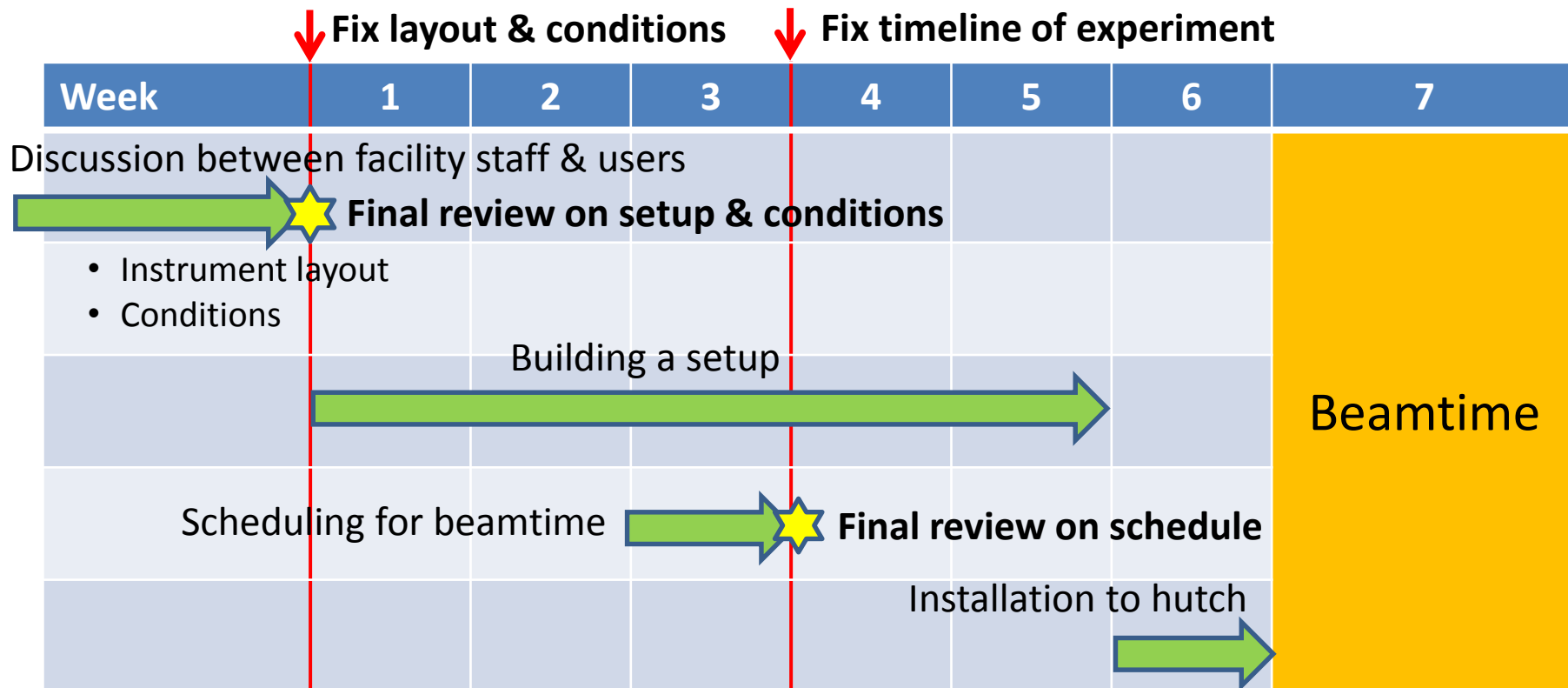
- Operation Phase 2 with 3 BLs is getting mature thorough two-year experiences, but we still have many things to develop.
 - Beam injection to SP-8.
 - More advanced instruments & more efficient operation.
 - Effective user support, etc...
- Opportunities have increased.
 - Over 6200 h user time (FY2018).
 - Strategic research programs.
- New capabilities at BLs.
 - BL1: Opto-spintronics experimental platform, Nano focusing system
 - BL2: MAXIC-S
 - BL3: Reflection self seeding, SDO
 - High power lasers (500 TW fs laser, 100 J ns laser)
- Input from the users is welcome, important for directing the facility's R&D activities (optics, detectors, lasers, etc...).
- For successful beamtime, we should start discussion on experimental plans as early as possible.

After obtaining approval of your proposal

- Contact beamline scientists:
sacla-bl.jasri@spring8.or.jp
- Start discussion as early as possible:
 - Provide *Practical* (not only conceptual) information for setting up your experiment.
 - Final plan should be fixed at least **6 weeks** prior to your beamtime.
- Make enough preparation:
 - Especially for experiments that need *non-standard* setup/bring-in apparatus.
 - If necessary, apply for feasibility-check beamtime (for SFX users).
- Do experiment:
 - Users are encouraged to operate instruments *by themselves*.
 - User-friendly platforms and program interface (ExpControl APIs) are available (see Posters)

Typical schedule for preparation by the facility staff

Well-planned preparation is a key to successful experiment.



- Final experimental plan: *~6 weeks* prior to the beamtime.
- Final timeline: *~3 weeks* prior.

Thank you for your attention!